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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No: 40296-0020

In re patent application of:
Sang Ho Woo et al.

Confirmation No.: 7832

Serial No.: 10/608,485

Art Unit: 2813

Filed: June 30, 2003

Examiner: THANHHA S. PHAM

For: CAPACITOR OF SEMICONDUCTOR DEVICE AND METHOD FOR
FABRICATING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 15, 2004, applicants hereby elect without traverse Group I, Claims 1-6, drawn to a method for fabricating a capacitor of a semiconductor device, for prosecution in the subject application. Applicants, of course, reserves the right to file one or more divisional applications covering the subject matter of the non-elected claims.

It is respectfully submitted that the application is in condition for examination, and an early action on the merits is courteously requested.

Respectfully submitted,

Date: October 14, 2004

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